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			Filing Date First Named Inventor				September 10, 2003 Hideakazu MIYAIRI et al.		
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Sheet	1	of 1	of 1		Attorney Docket Number			6-2650	
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				J.S. PATENT DOCU	MENT	S			
Puniner lakish	Cho Na.	U.S. Parati Document Number - Kind Code (f Known)		Publication Date: MC4-DD-YYYY		Name of Patentine or Applicant of Cital Document		Pages, Columns, Lines, Where Relevant Partages or Relevant Figures Appear	
(axials	Na.								
PN		US-6,166,845		12/26/2000		Ito et al.			
PN		US-2004/0203248 A1		10/14/2004		Miyairi et al.			
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Examiner initials	Cite include name of the author (in CAPITAL LETTERS), title of the article (when appropriats), title of the No. titem (book, magazine, journal, aerial, symptomum, catalog, etc.),, date, pegas), volume-issue number(s), publisher, city and/or country where published.								I _q
		Hideaki KUSAMA, "EXCIMER LASER ANNEALING APPARATUS", Liquid Crystal							
PN	Display Technology 2001, Liquid Crystal Display Manufacturing Technology Edition, pp. 138-141; July 1, 2001. (Japanese Article with Full Translation)								
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